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862.C2291

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Unassigned
KEIICHI IWAMURA)	
	:	Group Art Unit: Unassigned
Application No.: 09/901,684)	
	:	
Filed: July 11, 2001)	
	:	
For: INSPECTION METHOD AND)	December 6, 2001
SYSTEM	:	

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DEC 10 2001
Technology Center 2100

Commissioner for Patents
Washington, D.C. 20231

SECOND INFORMATION DISCLOSURE STATEMENT

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Ishizuka, et al., Ohnishi, et al., and the *Special Issue: Latest Agent Technology* references are cited in the specification at page 2, line 26; page 3, line 3, and page 14 line 19, respectively. An English language translation of the *Special Issue: Latest Agent Technology* reference is not presently available to the Applicant's attorney, but may be provided if required by the Examiner. Also, an English language abstract for the Japanese Patent Application also is enclosed as an English language statement of relevance for this reference.

Please note that in the Information Disclosure Statement filed on October 16, 2001, there was a typographical error found in the first named inventor for the reference entitled "A Method of Watermarking Under Frequency Domain for Protecting Copyright of Digital Image." Please correct the inventor's name to read **Takao Nakamura**, instead of Takao Nakmura.

FORMAL MATTERS

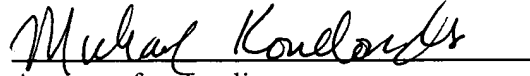
In accordance with 37 C.F.R. § 1.97(b), since a first Official Action on the merits of the subject application has not yet been issued, neither a certificate, petition nor payment of a fee is believed to be required for this Information Disclosure Statement. However, the Commissioner is hereby authorized to charge any fee which may be required in connection with this paper to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

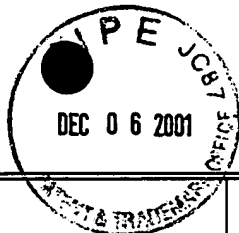
A handwritten signature in dark ink, appearing to read "Michael Kondoudis", is written over a horizontal line.

Attorney for Applicant

Michael E. Kondoudis

Registration No. 42,758

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
MEK/tmc



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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) December 6, 2001		ATTY DOCKET NO. 862.C2291		APPLICATION NO. 09/901,684			
		APPLICANT KEIICHI IWAMURA					
		FILING DATE July 11, 2001		GROUP Unassigned			
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		11-289255	10/19/1999	JAPAN			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Hirokazu ISHIZUKA, et al., "On an Experimental Evaluation of Steganography with Wavelet Transform" (SCIS January 29-February 1, 1997) (with English Abstract)					
		Junji OHNISHI, et al. "A Watermaking Scheme to Image Data by PN Sequence" (SCIS January 29-February 1, 1997) (with English Abstract)					
		"Special Issue: Latest Agent Technology" bit, Feb. 1999/Vol. 31, No. 2, pp. 2-34					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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